



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yasunori Ito, et al.
Serial No.: 10/640,850
Filed: August 13, 2003
For: METHOD OF PRODUCING
CERAMIC THERMISTOR
CHIPS
Group Art Unit: 1742
Examiner: H. D. Wilkins III
Attorney Docket: MURT P083D1

CERTIFICATE OF MAILING

Date of Deposit: February 20, 2007

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AMENDMENT "D"

Commissioner for Patents
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action dated November 13, 2006 in the above-referenced application, regarding which it is requested with the payment of a fee to extend the period for responding thereto by one month to March 13, 2006, applicant submits the following REMARKS together with the present status of the claims section: